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Case Docket No. FUSO3.001AUS



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Yokouchi et al.  
Appl. No. : 10/007,054  
Filed : December 3, 2001  
For : WAFER OXIDATION  
REACTOR AND A METHOD  
FOR FORMING A  
SEMICONDUCTOR DEVICE  
Examiner : Unknown  
Group Art Unit : 2811

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Thomas R. Arno, Reg. No. 40,490

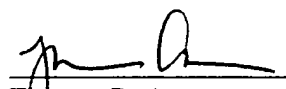
TRANSMITTAL LETTER

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Dear Sir:

Transmitted herewith is an Establishment of Right of Assignee to Take Action and Revocation of Power of Attorney in the above-identified application.

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